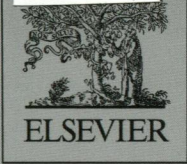


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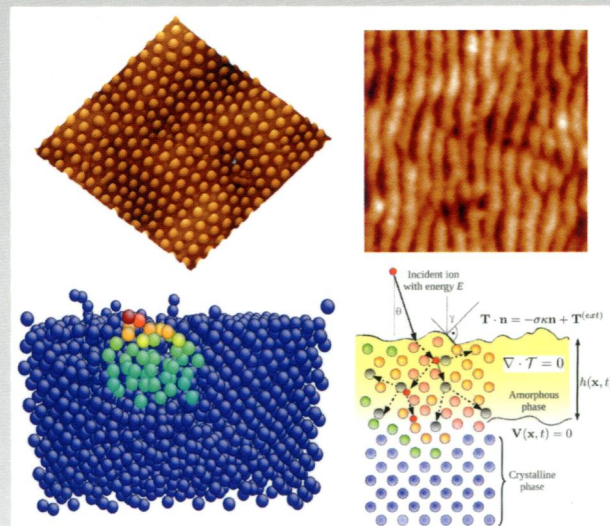
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# Self-organized nanopatterning of silicon surfaces by ion beam sputtering

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